

The most affordable AFM system for wafer measurement and analysis with the latest NX performance





Increase your productivity with our powerfully versatile AFM

The Most Convenient Sample Measurements with MultiSample Scan

- Automated imaging of multiple samples in one pass
- Specially designed multi-sample chuck for the loading of up to 16 individual samples (optionally available)
- Fully motorized XY sample stage travels up to 150 mm x 150 mm

Accurate XY Scan by Crosstalk Elimination

- Two independent, closed-loop XY and Z flexure scanners
- Flat and orthogonal XY scan with low residual bow
- More accurate height measurements enabled by NX electronic controller without any need for software processing

Best Tip Life, Resolution and Sample Preservation by True Non-Contact™ Mode

- Fast Z-servo speed enabling True Non-Contact™ Mode
- Minimum tip wear for prolonged high-quality and high-resolution imaging

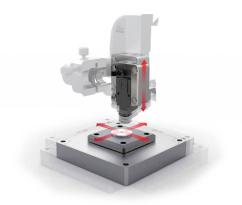
Versatile Range of Modes and Options

- Comprehensive set of measurement modes and characterizations
- Expanded capabilities with optional accessories and upgrades
- Advanced electrical measurements for failure analysis (FA)

AFM Technology

Flat Orthogonal XY Scanning without Scanner Bow

Park's Crosstalk Elimination scanner structure removes scanner bow, allowing flat orthogonal XY scanning regardless of scan location, scan rate, and scan size. It shows no background curvature even on flattest samples, such as an optical flat, and with various scan offsets. This provides you with a very accurate height measurement and precision nanometrology for the most challenging problems in research and engineering.

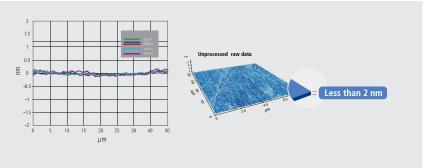


Decoupled XY and Z Scanners

The fundamental difference between Park and its closest competitor is in the scanner architecture. Park's unique flexure based independent XY scanner and Z scanner design allows unmatched data accuracy in nano resolution further improved with NX AFM Head (Z scanner) powered by NX AFM electronic controller.

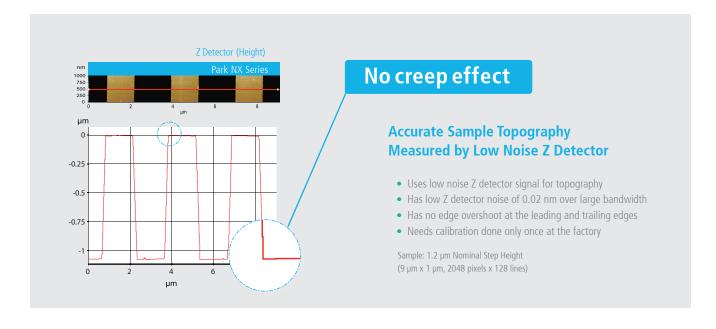
Accurate Surface Measurement "Flat" sample surface as it is!

- Low residual bow
- No need for software processing
- Accurate results independent of scan location
- Less than 2 nm of out-of-plane motion with the NX electronic controller



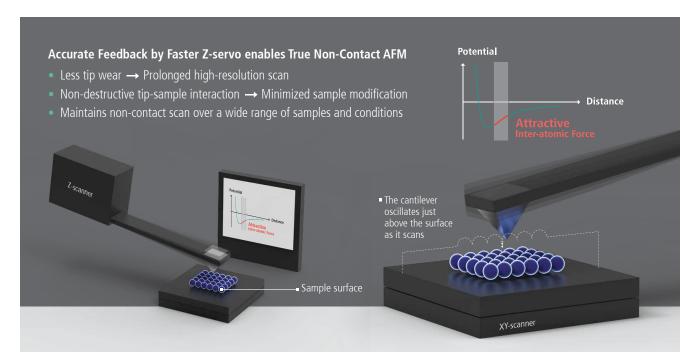
Industry Leading Low Noise Z Detector

Park AFMs are equipped with the most effective low noise Z detectors in the field, with a noise of 0.02 nm over large bandwidth. This produces highly accurate sample topography and no edge overshoot. Just one of the many ways Park NX series saves you time and gives you better data.

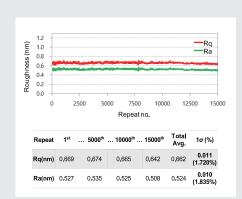


True Non-Contact™ Mode

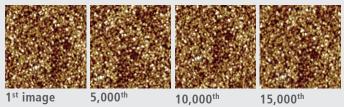
True Non-Contact™ Mode is a scan mode unique to Park AFM systems that produces high resolution and accurate data by preventing destructive tip-sample interaction during a scan.



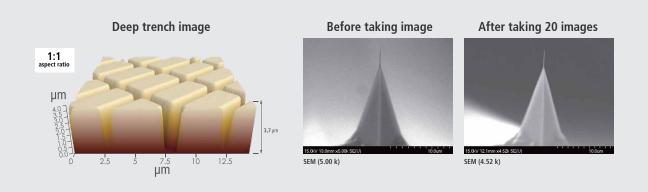
Unlike in contact mode, where the tip contacts the sample continuously during a scan, or in tapping mode, where the tip touches the sample periodically, a tip used in non-contact mode does not touch the sample.



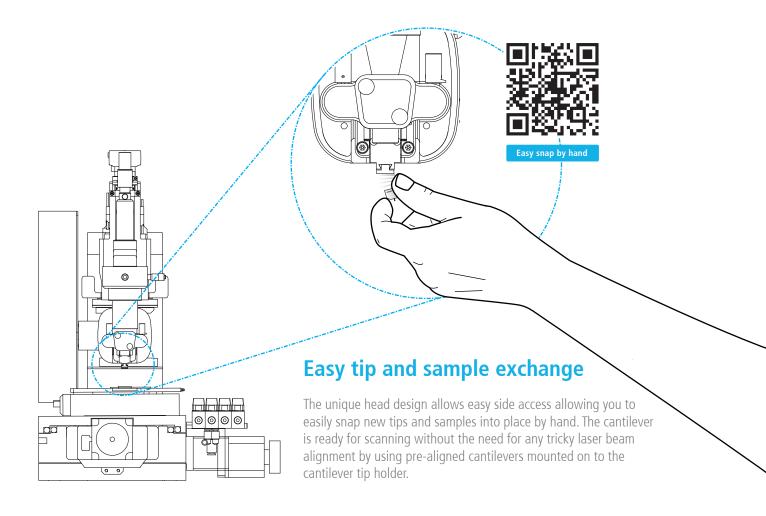
Because of this, use of non-contact mode has several key advantages. Scanning at the highest resolution throughout imaging is now possible as the tip's sharpness is maintained. Non-contact mode avoids damaging soft samples as the tip and sample surface avoid direct contact.



Furthermore, non-contact mode senses tip-sample interactions occurring all around the tip. Forces occurring laterally to tip approach to the sample are detected. Therefore, tips used in non-contact mode can avoid crashing into tall structures that may suddenly appear on a sample surface. Contact and tapping modes only detect the force coming from below the tip and are vulnerable to such crashes.



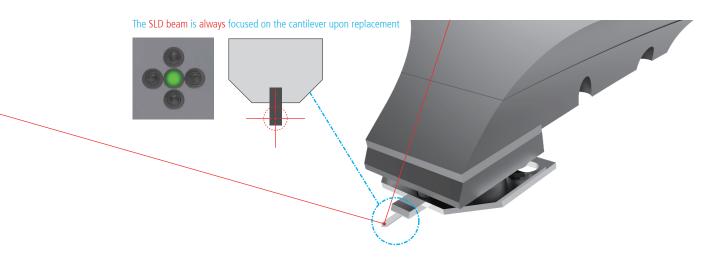
Why the world's most accurate small sample AFM is also the easiest to use



Easy, intuitive SLD beam alignment

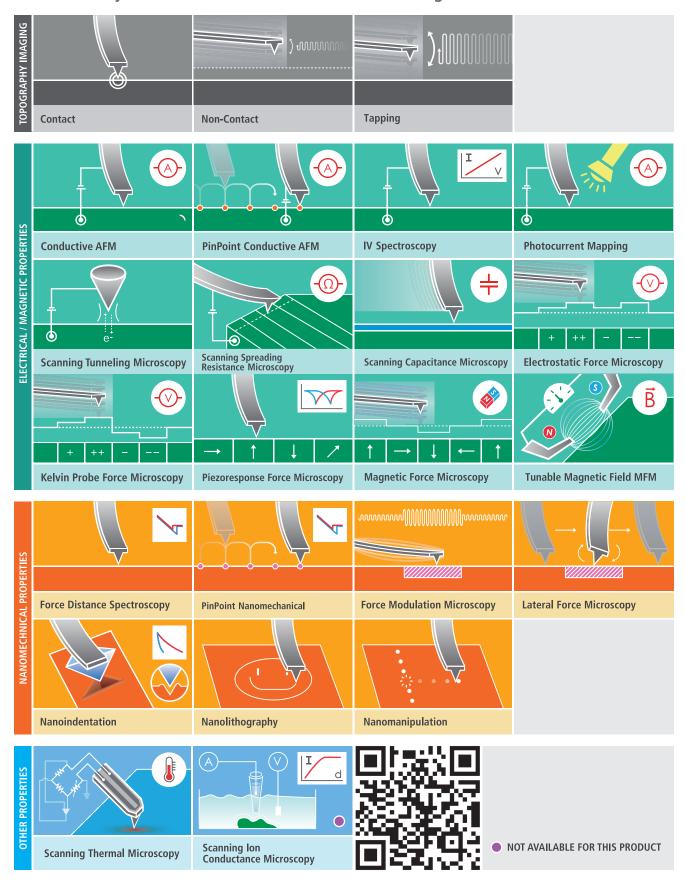
With our advanced pre-aligned cantilever holder, the SLD beam is focused on the cantilever upon placement. Furthermore, the natural on-axis, top-down view allows you to easily find the SLD spot. Since the SLD beam falls vertically onto the cantilever, you can intuitively move the SLD spot along the X- and Y -axis by rotating two positioning knobs. As a result, you can easily find the SLD and position it onto the position-sensitive photodiode using our operation software's beam alignment user interface. From there, all you will need is a minor adjustment to maximize the signal prior to starting data acquisition.

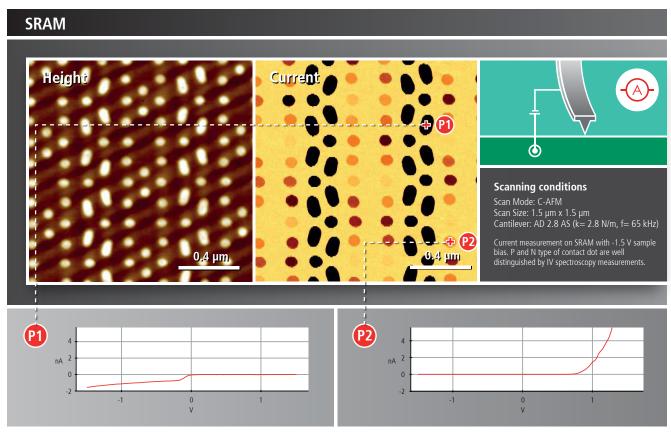


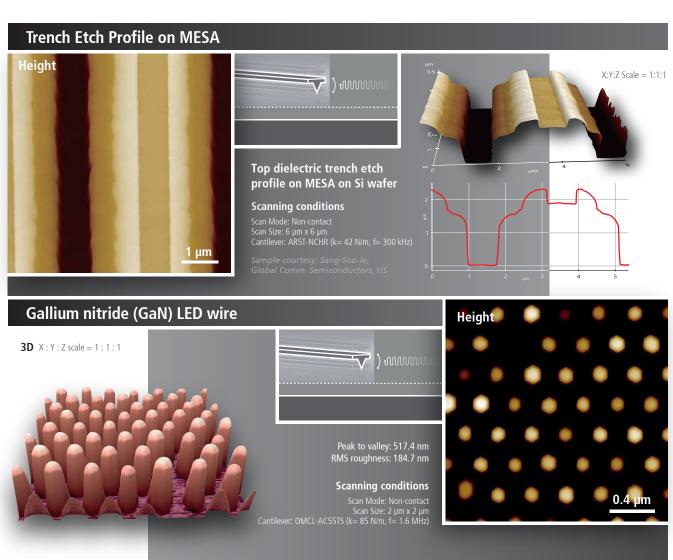


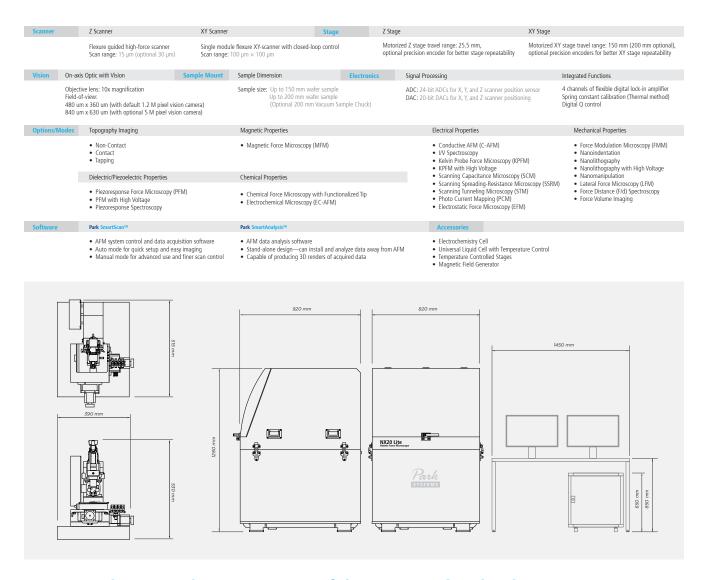
Park Atomic Force Microscopy Modes

Get the data you need with Park's selection of scanning modes









Committed to contributing to impactful science and technology

Park Systems Corporation is a leading manufacturer of nanoscale microscopy and metrology solutions that encompasses the atomic force microscopy, white light interferometry, infrared spectroscopy and ellipsometry systems. Its products are widely used for scientific research, nanoscale engineering, and semiconductor fabrication and quality assurance. Park Systems provides a full range of AFM products from desktop to fully automated systems with integrated robotic arms. Furthermore, its product line includes WLI AFM, Photo-induced Force Microscopy spectroscopy and ellipsometry systems for those in the chemistry, materials, physics, life sciences, and semiconductor industries. In 2022, Park Systems acquired and merged Accurion GmbH, a leader in high-end ellipsometry and active vibration isolation, to form Park Systems GmbH, Accurion Division.

Park Systems is a publicly traded corporation on the Korea Stock Exchange (KOSDAQ) with corporate headquarters in Suwon, Korea, and regional headquarters in Santa Clara, California, Mannheim, Germany, Paris, France, Beijing, China, Tokyo, Japan, Singapore, India, and Mexico. To learn more, please visit www.parksystems.com.

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